Kluwer Patent Blog

G1/09 pending application, European Patent Office (Appeals Court), 29 September 2010

Lars de Haas (V.O.) · Monday, November 15th, 2010

The Enlarged Board of Appeal answered the question referred to it by the Board of Appeal in J 2/08.

The Enlarged Board of Appeal held that after a decision to refuse a European patent application, the application remains pending, in the sense that a divisional application can be validly filed, until the expiry of the time limit for filing a notice of appeal, when no appeal is filed.

A **full summary** of this case has been published on **Kluwer IP Law**.

_____

To make sure you do not miss out on regular updates from the Kluwer Patent Blog, please subscribe here.
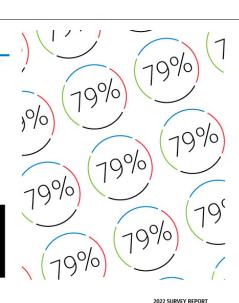
Kluwer IP Law

The **2022 Future Ready Lawyer survey** showed that 79% of lawyers think that the importance of legal technology will increase for next year. With Kluwer IP Law you can navigate the increasingly global practice of IP law with specialized, local and cross-border information and tools from every preferred location. Are you, as an IP professional, ready for the future?

Learn how **Kluwer IP Law** can support you.

This entry was posted on Monday, November 15th, 2010 at 4:29 pm and is filed under Case Law, electricity, electronics, and electromagnetism and includes control systems, medical electrical engineering, electrical energy systems, high-performance electronics, robotics, electric motors, digital and analogue circuits, circuit topologies, oscillators, amplifiers, filters, semiconductor components, silicon-based components, semiconductor systems, sensors, transistors, passive components, MEMs, smartcards, signal processing systems, digital signal processing, coding techniques, computer-related inventions, computer technology, embedded software, telecommunications, GSM/UMTS/CDMA systems and typologies, telecommunications coding techniques, positioning technologies, TFT/LCD/Plasma/(O)LED displays, Plasma physics, Solar cells, Semiconductor physics, Deposition techniques, etching techniques, thin film techniques, epitaxy techniques, Plasma processing, MRI, Thermodynamics, Nuclear physics, Nuclear energy, Nuclear applications in medicine, Geophysics, Aerodynamics, Sustainable energy technologies, Computational physics">Electrical Engineering, EPC, Procedure

You can follow any responses to this entry through the Comments (RSS) feed. Both comments and pings are currently closed.